

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

BAKKER et al.

Application No.: TO BE ASSIGNED Group Art Unit: UNKNOWN

Filed: August 21, 2003 Examiner: UNKNOWN

Title: LITHOGRAPHIC PROJECTION APPARATUS AND
PARTICLE BARRIER FOR USE THEREIN

* * * *

August 21, 2003

INFORMATION DISCLOSURE STATEMENT

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

EP 1 274 287 A2, cited in the Search Report, has not been submitted or listed as its U.S. equivalent, 2003/0020890, has been listed instead. The undersigned respectfully notes that copies of U.S. references are not required in applications filed after June 30, 2003.

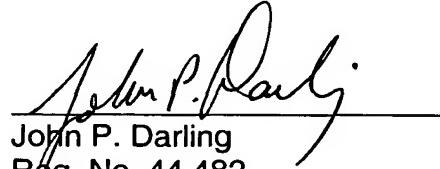
This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

BAKKER et al.

Some of the references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

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FORM PTO-1449 (modified) To: U.S. Department of Commerce (PW FORM PAT-1449) Patent and Trademark Office				Atty. Dkt. No.	M#	Client Ref.
					305541	P-0352.010-US
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant: BAKKER et al.		
				Appln. No.: TO BE ASSIGNED		
				Filing Date: August 21, 2003		
Date: August 21, 2003		Page 1 of 1	Examiner:		Group Art Unit:	

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	4,408,338	10/1983	GROBMAN			
BR	6,262,796	07/2001	LOOPSTRA et al.			
CR	6,359,969	03/2002	SHMAENOK			
DR	2002/0084428	07/2002	VISSEER et al.			
ER	2002/0090054	07/2002	SOGARD			
FR	2002/0154279	10/2002	KOSTER et al.			
GR	2003/0020890	01/2003	MIYAKE et al.			
HR	2003/0095623	05/2003	SINGER et al.			
IR						
JR						
KR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
LR	2000-349009	12/2000	JAPAN	OTA		X		
MR								
NR								
OR								
PR								
QR								
RR								
SR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

TR	Partlo et al., "Development of an EUV (13.5nm) Light Source Employing a Dense Plasma Focus in Lithium Vapor," <i>Proc. of SPIE</i> Vol. 3997:136-156, Emerging Lithographic Technologies IV, ed. E. Dobisz (March 2000)		
UR	McGeoch, "Power Scaling of a Z-Pinch Extreme Ultraviolet Source," <i>Proc. of SPIE</i> Vol. 3997:861-866, Emerging Lithographic Technologies IV, ed. E. Dobisz (March 2000)		
VR			
WR			
XR			
YR			
ZR			

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.